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NO. 7723 P. 1

PTO/SB/07 (08-03)

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Raquej Garcia

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Application Number See attached Schedule A

Filing Date See attached Schedule A

In re of Applicant: Tokyo Ohka Kogyo Co., Ltd.

Art Unit unassigned

Examiner Name unassigned

Attorney Docket Number See attached Schedule A

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Change of Correspondence Address with attached Schedule A (3 pages)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re of Applicant: Tokyo Ohka Kogyo Co., Ltd. Docket No.: See attached Schedule A
Serial No.: See attached Schedule A Art Unit: Not yet designated
Filing Date: See attached Schedule A Examiner: Not yet designated

Commissioner for Patents
P.O. Box 1450
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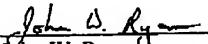
CHANGE OF CORRESPONDENCE ADDRESSES

Applicants respectfully requests the Examiner to change the correspondence address for the following applications as listed in the attached Schedule A to the address associated with the attorney of record:

Customer No.:	38,552		
Individual Name:	John W. Ryan		
Firm Name:	Dechert, LLP		
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If necessary, please charge any fees in connection with this submission or credit any overpayments to our Deposit Account No. 50-2787. If you have any questions regarding this submission, please contact the undersigned attorney at the local Washington DC office.

Respectfully submitted,


John W. Ryan
Registration No. 33,771

Date: December 7, 2004

DECHERT, LLP
1775 I Street, N.W.
Washington, DC 20006

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PAGE 2/5 *RCVD AT 12/7/2004 12:01:36 PM [Eastern Standard Time]* SVR:USPTO-EFXRF-1/1*DNIS:8729306*CSID:202 261 3333*DURATION (mm:ss):01:14

Schedule A
Change of Correspondence Address
Client: Tokyo Ohka Kogyo Co., Ltd
Customer Number: 38,552

NO. 7723 **Attorney Docket:** 372106-101
Title: Resist Developer and Resist Pattern Formation Method Using Same

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10422,548	24-Apr-2003

Attorney Docket: 372106-102

Title: SILICA-BASED ORGANIC FILM AND METHOD OF
MANUFACTURING THE SAME, AND BASE MATERIAL
COMPRISING ORGANIC FILM

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10616,731	10-Jul-2003
US	10800,822	15-Mar-2004

Attorney Docket: 372106-103

Title: POSITIVE TYPE RESIST COMPOSITION AND RESIST
PATTERN FORMATION METHOD

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10466,72	14-Jun-2003

Schedule A

Change of Correspondence Address
Client: Tokyo Ohka Kogyo Co., Ltd
Customer Number: 38,552

NO. 7723

Attorney Docket: 372106-104**Title:** POSITIVE TYPE RESIST COMPOSITION AND RESIST

PATTERN FORMATION METHOD

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10466,473	14-Jul-2003

Attorney Docket: 372106-105**Title:** PHOTORESIST PATTERN AND FORMING METHOD THEREOF**Client:** Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10628,919	29-Jul-2003

Attorney Docket: 372106-106**Title:** Positive Type Resist Composition and Resist Pattern Formation

Method Using Same

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10467,130	01-Aug-2003

Attorney Docket: 372106-107**Title:** BASE MATERIAL FOR LITHOGRAPHY

Client

Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10648,782	25-Aug-2003

DEC. 7, 2004

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Schedule A
Change of Correspondence Address
Client: Tokyo Ohka Kogyo Co., Ltd
Customer Number: 38552

NO. 7723

Attorney Docket: 372106-108
Title: Preparation for Nano Material, Metal Oxide Nano Material Formation

Composition Used for the Method, Mold and Metal Oxide Nano Structure

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/840,192	05-May-2004

Attorney Docket: 372106-109
Title: Resist Composition

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/845,620	13-May-2004

Attorney Docket: 372106-110
Title: Positive Resist Composition and Formation Method of Resist Pattern

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/859,904	03-Jun-2004

1:03PM *Attorney Docket:* 372106-111
Title: Positive Resist Composition and Resist Pattern Forming Method

Client: Tokyo Ohka Kogyo Co., Ltd.

Country	Application Number	Filing Date
US	10/865,040	10-Jun-2004